

INVENTOR INFORMATION

Inventor One Given Name: Shigeyuki
Family Name: YEAWA
City of Residence: Tokyo
Country of Residence: Japan
Citizenship: Country: Japan

APPROPRIATE INFORMATION

Representative Customer Number: 0014
Fax: 010-010-3300

APPLICATION INFORMATION

Title Line One: EXPOSURE APPARATUS, DEVICE MANUFACTURING
Title Line Two: METHOD, SEMICONDUCTOR MANUFACTURING PLANT AND
Title Line Three: METHOD OF MAINTAINING EXPOSURE APPARATUS

Total Drawing Sheets: 6
Formal Drawings: Yes
Application Type: Utility
Project Number: 801.02235
Priority Order in Parent Appl.: No

REPRESENTATIVE INFORMATION

Representative Customer Number: 0014

FILED FOREIGN APPLICATION

Foreign Application No: 1 -103-45
Filing Date: 8-31-2000
Country: Japan
Priority Claimed: Yes